

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|----------------|---|---|
| Applicant      | : | Sherman                                 |
| Appl. No.      | : | 10/683,727                              |
| Filed          | : | October 10, 2003                        |
| For            | : | SEQUENTIAL CHEMICAL<br>VAPOR DEPOSITION |
| Examiner       | : | Kelly M. Stouffer                       |
| Group Art Unit | : | 1762                                    |

**AMENDMENT AND RESPONSE TO OFFICE ACTION****Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Office Action mailed on October 31, 2006. Applicant respectfully requests consideration of the subsequent remarks.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.